

250	346P
Class	Subclass
ISSUE/CLASSIFICATION	

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED <i>TD2</i> O.A. <i>UR</i>	

APPLICATION NO. 09/819906	CONT/PRIOR F	CLASS 250	SUBCLASS 37.01	ART UNIT 2881	EXAMINER NGUYEN
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APPLICANTS
Yasuhiko Shimada
Takeyuki Yagi
Haruhito Ono
Hiroshi Maehara

Electron optical system array, method of manufacturing the same,
charged-particle beam exposure apparatus, and device manufacturing
method

PTO-2040
12/99

ISSUING CLASSIFICATION

ORIGINAL				CROSS REFERENCE(S)									
CLASS		SUBCLASS		CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)								
250		396R		250	492.2								
INTERNATIONAL CLASSIFICATION													
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				37/302									

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**TERMINAL
DISCLAIMER**



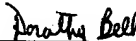
☒ The term of this patent subsequent to _____ has been disclaimed.

☐ The term of this patent not extend beyond the expiration of U.S. Patent. No. _____

☐ The terminal _____ months of this patent have been disclaimed.

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DRAWINGS			CLAIMS ALLOWED	
Sheets Drwg. 14	Figs. Drwg. 32	Print Fig. 1	Total Claims 25	Print Claim for O.G. 1
 _____ (Assistant Examiner)			NOTICE OF ALLOWANCE MAILED	
 KIET T. NGUYEN PRIMARY EXAMINER 02-18-04 _____ (Primary Examiner)			2-24-04 ISSUE FEE	
			Amount Due \$ 1630	Date Paid
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Drawing

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